

**REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL**

Application Number	10/586,849
Confirmation Number	3462
Filing Date	July 20, 2006
First Named Inventor	Hisayuki MIKI
Group Art Unit	2814
Examiner Name	Wai Sing LOUIE
Matter Number	Q79703
Title	GALLIUM NITRIDE-BASED COMPOUND SEMICONDUCTOR MULTILAYER STRUCTURE AND PRODUCTION METHOD THEREOF

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,
provides for continued examination of an utility or
plant application filed on or after June 8, 1995

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

1. SUBMISSION REQUIRED UNDER 37 C.F.R. § 1.114

- a. ☒ Previously submitted
- i. ☒ Please enter and consider the amendment(s)/reply under 37 C.F.R. § 1.116
previously filed on March 4, 2009
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
- iii. ☐ Other _____
- b. ☒ Enclosed
- i. ☐ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statements (IDS)
- iv. ☒ Petition for Extension of Time
- v. ☐ Other _____

2. MISCELLANEOUS

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a
period of _____ months
- b. ☐ Other _____

3. FEES

The USPTO is directed and authorized to charge the RCE statutory fee of \$810.00 and all required fees, except
for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said
Deposit Account.

CORRESPONDENCE ADDRESS

Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below:


WASHINGTON OFFICE

23373

CUSTOMER NUMBER

SIGNATURE OF ATTORNEY

Name Jerrick J. Ho Registration No. 63,763

Signature  Date April 1, 2009